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SEP 2 7 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| Application Serial No | 10/773,780 |
|---|---|
| | 7887 |
| Filing Date | February 9, 2004 |
| | |
| | Micron Technology, Inc |
| Group Art Unit | 2825 |
| | Calvin Lee |
| | Ml22-2498 |
| | 021567 |
| Title: Capacitor Constructions Comprising | ng Agglomerates Of One Or More Noble Metals |

RESPONSE TO JULY 2, 2004 OFFICE ACTION

To:

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

By Facsimile 1 (703) 872-9306

From:

David G. Latwesen, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)

Wells St. John P.S.

601 W. First Avenue, Suite 1300 Spokane, WA 99201-3828

<u>AMENDMENTS</u>

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